

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Yoshichika Kato
Docket No.: KPO180
Title: Micromachined moving device

July 25, 2003
San Francisco, California

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:


Pursuant to the duty of disclosure set forth in 37 CFR § 1.56, Applicant respectfully submits the following information disclosure statement.

The disclosed reference is:

JP 2001-264650; Japanese Patent Office; published September 26, 2001, with English Abstract.

Applicant respectfully requests that the Examiner initial the cited references shown on the enclosed form PTO-1449 and that the references be made of record in the present application.

Respectfully submitted,


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Certificate of Mailing Under 37 CFR 1.10

I certify that this Information Disclosure Statement and any enclosed materials are being deposited with the United States Postal Service on July 25, 2003 as "Express Mail," mailing label EV326498405US, in an envelope addressed to Mail Stop Patent Application, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.


Jean C. Reed

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